

**Search Notes****Application/Control No.**

10/762,210

**Examiner**

Taeyoon Kim

**Applicant(s)/Patent under Reexamination**

BERENSON ET AL.

**Art Unit**

1651

**SEARCHED**

Class	Subclass	Date	Examiner
435	375	6/2/2008	TK
435	325	6/2/2008	YK
435	372.3	6/2/2008	TK

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
updated search: classification, interference search	6/2/2008	TK

**INTERFERENCE SEARCHED**

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